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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/637,094	08/06/2003	Bruno Ghyselen	4717-6300	9064	
28765 75	90 09/19/2005		EXAMINER		
WINSTON & STRAWN LLP			PHAM, THANH V		
1700 K STREET, N.W. WASHINGTON, DC 20006			ART UNIT	PAPER NUMBER	
			2823		
			DATE MAILED: 09/19/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

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Advisory Action Before the Filing of an Appeal Brief

Application No.	Applicant(s)		
10/637,094	GHYSELEN ET AL.		
Examiner	Art Unit		
Thanh V. Pham	2823		

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The MAILING DATE of this communication appear	ars on the cover sheet with the o	correspondence add	ress					
THE REPLY FILED 02 September 2005 FAILS TO PLACE THIS APPLICATION IN CONDITION FOR ALLOWANCE.								
1. The reply was filed after a final rejection, but prior to or on this application, applicant must timely file one of the follow places the application in condition for allowance; (2) a Nor a Request for Continued Examination (RCE) in compliance time periods:	ring replies: (1) an amendment, affitice of Appeal (with appeal fee) in a	fidavit, or other evider compliance with 37 C	ice, which FR 41.31; or (3)					
 a) The period for reply expires 3 months from the mailing date b) The period for reply expires on: (1) the mailing date of this A no event, however, will the statutory period for reply expire la 	dvisory Action, or (2) the date set forth							
Examiner Note: If box 1 is checked, check either box (a) or (TWO MONTHS OF THE FINAL REJECTION. See MPEP 70	b). ONLY CHECK BOX (b) WHEN THI							
Extensions of time may be obtained under 37 CFR 1.136(a). The date have been filed is the date for purposes of determining the period of extunder 37 CFR 1.17(a) is calculated from: (1) the expiration date of the set forth in (b) above, if checked. Any reply received by the Office later may reduce any earned patent term adjustment. See 37 CFR 1.704(b) NOTICE OF APPEAL	on which the petition under 37 CFR 1. ension and the corresponding amount hortened statutory period for reply orig than three months after the mailing da	of the fee. The appropr pinally set in the final Offi	ate extension fee ce action; or (2) as					
 The Notice of Appeal was filed on A brief in comp filing the Notice of Appeal (37 CFR 41.37(a)), or any exter a Notice of Appeal has been filed, any reply must be filed AMENDMENTS 	nsion thereof (37 CFR 41.37(e)), to	o avoid dismissal of th						
 The proposed amendment(s) filed after a final rejection, l (a) They raise new issues that would require further contains 			ecause					
 (b) They raise the issue of new matter (see NOTE belo (c) They are not deemed to place the application in bet appeal; and/or 		educing or simplifying	the issues for					
(d) They present additional claims without canceling a NOTE: (See 37 CFR 1.116 and 41.33(a)).	corresponding number of finally re	jected claims.						
4. The amendments are not in compliance with 37 CFR 1.13		ompliant Amendment	(PTOL-324).					
 Applicant's reply has overcome the following rejection(s) Newly proposed or amended claim(s) would be al non-allowable claim(s). 	lowable if submitted in a separate,							
7. For purposes of appeal, the proposed amendment(s): a) how the new or amended claims would be rejected is protected. The status of the claim(s) is (or will be) as follows: Claim(s) allowed:		ill be entered and an e	explanation of					
Claim(s) objected to: Claim(s) rejected: 1-20 and 23-26. Claim(s) withdrawn from consideration:								
AFFIDAVIT OR OTHER EVIDENCE								
 The affidavit or other evidence filed after a final action, bu because applicant failed to provide a showing of good and was not earlier presented. See 37 CFR 1.116(e). 	d sufficient reasons why the affida	vit or other evidence i	s necessary and					
9. The affidavit or other evidence filed after the date of filing entered because the affidavit or other evidence failed to of showing a good and sufficient reasons why it is necessary	vercome <u>all</u> rejections under appe y and was not earlier presented. S	eal and/or appellant fa See 37 CFR 41.33(d)(ils to provide a 1).					
10. ☐ The affidavit or other evidence is entered. An explanatio REQUEST FOR RECONSIDERATION/OTHER	n of the status of the claims after ϵ .	entry is below or attac	ned.					
11. The request for reconsideration has been considered bu	t does NOT place the application i	in condition for allowa	nce because:					
12. Note the attached Information Disclosure Statement(s). 13. Other:	(PTO/SB/08 or PTO-1449) Paper I	No(s)						

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Response to Amendment

1. Claim 18 is objected to because of the following informalities: the new status of the claim should be --Currently Amended--. Appropriate correction is required.

2. The amendment of claim 26 overcomes the objection of this claim.

Response to Arguments

- 3. Applicant's arguments filed 09/02/2005 have been fully considered but they are not persuasive.
- 4. Applicant contradicts himself by stating that "the claims require that, in a <u>single</u> <u>step</u>, the thickness of the very same layer that was measured be changed <u>according to</u> <u>the results of its measurement</u>." The actual step 105' of instant fig. 2 is not as that simple and includes four sub-steps: step 1051' of acquiring a measured thickness profile, step 1052' of deducing adjusting thickness specification to be applied, step 1053' of adjustment thickness and step 1054' of additional step. Those steps are not a single step as same as claimed in claim 1 and the steps in Vuong's fig. 2.
- 5. Applicant argues that the instant "Fig. 1 illustrates a prior art fabrication process, which is, incidentally, similar to that disclosed by Vuong". The examiner does not agree. The explanation is as in the above and further below.
- 6. Applicant argues that "neither these paragraphs specifically nor Vuong <u>as a</u>

 <u>whole</u>, in fact, disclose, explicitly or inherently, adjusting or changing the thickness of a

semiconductor layer according to a thickness adjustment specification as claimed." And "fabrication process data or experience is not by itself changing a layer thickness".

One cannot show nonobviousness by attacking references individually where the rejections are based on combinations of references. See *In re Keller*, 642 F.2d 413, 208 USPQ 871 (CCPA 1981); *In re Merck & Co.*, 800 F.2d 1091, 231 USPQ 375 (Fed. Cir. 1986). In this instance, applicant attacks each and individual passage quoted in the rejection of the Final Office action and ignores the fact that Vuong, as a whole, discloses the instant invention.

Further, applicant is directed to step 398 of Vuong's fig. 2 wherein "<u>use</u> results of profile and parameter selection for fabrication in cluster loop control" or Vuong's paragraph [0054] wherein "the results of profile model and parameter selection <u>are utilized</u> for fabrication cluster feed-forward or feed-backward control loops. Details of this aspect are discussed in FIG. 6C". Furthermore, the Vuong's [0005], as a whole, teaches "knowledge of the <u>dimensions</u> of the gratings or periodic structures is essential in order to <u>determine</u> if the <u>dimensions of the structure</u> are within acceptable ranges", this, in combination with the results of profile model and parameter (including the thickness as one dimension of the structure) "<u>are utilized</u>" or <u>used</u> in the fabrication cluster 1940. After the steps of measuring, comparing and selecting a profile (the same as the first three steps of claim 1), the results of profile model and parameter selection <u>are utilized</u> or <u>used</u> in changing a layer thickness, as one of the parameter variables, in the fabrication cluster (the same as the last step of claim 1).

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7. Applicant also contradicts himself by stating that "claimed method is single, independent step that changes the thickness of the very same layer it is currently processing. No feedback or feed-forward information is provided to or received from any other process steps". The step of "comparing the measured thickness profile with stored standard profiles" is considered a feedback step where the measured thickness is feedback (to a 'computer') to be compared with stored data. How can a measured thickness is compared with stored standard profiles if not being the back to be compared? And the same with the step of "selecting a stored standard profile" plus "adjusting the actual thickness in accordance with the thickness adjustment specification" is considered the feed-forward step.

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8. Applicant is wrong in the statement "[B]ut Vuong discloses here and throughout only a feedback or feedforward process ... for <u>future</u> wafers and <u>cannot be used</u> to change the thickness of the "complete wafer". Applicant further recognizes: "Paragraph 96 states: "alternatively, the regression results <u>may be used to adjust variables</u> and/or physical controls of the fabrication process"; and then alleges: "This is <u>no more than a hypothetical suggestion</u> and <u>not an actual disclosure</u> of anything, much less of changing the thickness of a layer from which the regression results were obtained."

Applicant is directed back to the quoted passages in the Final office action,

Vuong's [0072], wherein "several tasks may be concurrently or serially performed";

[0091], "in-line requests 1931 for the same data is transmitted from an optical metrology system 1930 ... The critical dimension data 1942 may be used by the fabrication cluster 1940 to adjust process variables of the fabrication process"; [0096], "the regression

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claimed invention.

results such as ... <u>film thickness</u>, and profile from the parameter selector ... may be used by a system user to <u>fine-tune</u> the ... fabrication process"; and therefore, "results may be used to adjust variables and/or physical controls of the fabrication process" in [0096], is, really/actually, a "suggestion" of Vuong that discloses/anticipates the instant

9. Applicant's statement "Profile models and "thickness adjustment specification" are entirely different data" is responded as in the above wherein the measured thickness is compared with the stored data from the parameter selector to select/adjust the process variables to get the better thickness adjustment specification to be performed or to fine-tune the film thickness, in the fabrication cluster as Vuong's

10. The argument on Wolf is moot in view of Vuong as described in the Final rejection.

11. In view of the above, the rejections are maintained as in the Final Office action mailed 05/03/2005.

TOP

09/12/2005

anticipation.

Primary Examiner